## **Knobbe Martens Olson & Bear LLP**

Intellectual Property Law

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September 6, 2011

ATTN: Certificate of Correction Branch Commissioner for Patents P.O. Box 1450 Alexandria, CA 22313-1450

Re:

U.S. Patent Application No. 10/590,046

Patent No: 7,923,192

Title: BASI

BASE MATERIAL FOR PATTERN-FORMING MATERIAL, POSITIVE RESIST

COMPOSITION AND METHOD OF RESIST PATTERN FORMATION

Issue Date: April 12, 2011

Our Reference: SHIGA7.055APC

Dear Sir:

Enclosed for filing is a Certificate of Correction in connection with the above-identified patent.

As the errors cited in the Certificate of Correction were incurred through the fault of the Patent Office, no fee is believed to be required. However, please charge our Deposit Account No. 11-1410 for any fees that may be incurred with this request.

Respectfully submitted,

Knobbe, Martens, Olson & Bear, LLP

Registration No. 39,901 Customer No. 20995

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